



843.43437X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: TOKUNAGA, *et al.*

Serial No.: 10/764,563

Filed: January 27, 2004

For: METHOD OF PURGING WAFER RECEIVING JIG, WAFER
TRANSFER DEVICE, AND METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

STATUS LETTER AND REQUEST FOR OFFICIAL FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 29, 2003

Sir:

Applicants note that the office of the undersigned has not received the
Official Filing Receipt for the above-identified application and applicants
respectfully request the Official Filing Receipt.

An early response to this request is earnestly solicited.

Respectfully submitted,

Antonelli, Terry, Stout & Kraus, LLP

William I. Solomon
Registration No. 28,565

WIS/rr